Docket No.: 60188-705 **PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Manabu TAKAHASHI, et al. : Confirmation Number:

Serial No.: : Group Art Unit:

Filed: November 19, 2003 : Examiner:

For: SEMICONDUCTOR DEVICE AND CONTROL METHOD

## **CLAIM OF PRIORITY**

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

Japanese Patent Application No. 2002-335612, filed November 19, 2002

A Certified copy will be filed in due course.

Respectfully submitted,

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Date: November 19, 2003